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BIBDATASHEET

Bib Data Sheet

CONFIRMATION NO. 4127

SERIAL NUMBER 09/785,815	FILING DATE 02/16/2001	CLASS 156	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 4969/USA/ISM/COPPER/SB
	RULE			

APPLICANTS

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Bernardo Donoso, San Jose, CA; Joseph J. Stevens, San Jose, CA;

** CONTINUING DATA *****

This appln claims benefit of 60/237,908 10/04/2000
 and is a CIP of 09/350,210 07/09/1999 PAT 6,267,853
 and is a CIP of 09/350,212 07/09/1999 PAT 6,516,815
 and is a CIP of 09/614,406 07/12/2000 PAT 6,494,219

SM

** FOREIGN APPLICATIONS *****

None

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 07/09/2003

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY CA	SHEETS DRAWING 7	TOTAL CLAIMS 22	INDEPENDENT CLAIMS 3
Verified and Acknowledged Examiner's Signature <i>SM</i> Initials <i>SM</i>					

ADDRESS

32588
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TITLE

Integrated semiconductor substrate bevel cleaning apparatus and method

All Fees
 1.16 Fees (Filing)